



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2892
Examiner: Mr. William F. Kraig

In re PATENT APPLICATION of:

Applicant	:	Akira TAKAHASHI)	
)	
Serial No.	:	10/798,482)	SUPPLEMENTAL
)	<u>AMENDMENT</u>
Filed	:	March 12, 2004)	
)	
For	:	DRY ETCHING METHOD FOR)	
		SEMICONDUCTOR DEVICE)	
)	
Attorney Ref.	:	OKI 414)	
)	

January 12, 2011

Mail Stop Amendment
Director of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Supplemental to the Amendment filed on September 21, 2010, please further amend the above-identified application as specified on the following pages.